



500.42846X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: M. HASEGAWA, et al.

Serial No.: 10/628,275

Filed: July 29, 2003

For: STAMPER, LITHOGRAPHIC METHOD OF USING THE
STAMPER AND METHOD OF FORMING A STRUCTURE BY A
LITHOGRAPHIC PATTERN

Group: 1763

Examiner: Roberts P. CULBERT

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR 1.97 & 1.98

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 13, 2006

Sir:

Pursuant to Applicants' duty of disclosure, enclosed please find copies of documents cited in connection with a Notice of Reason For Rejection dated March 14, 2006, in connection with a corresponding Japanese Patent Application. Also enclosed are English abstracts of each of the respective enclosed documents. Further enclosed is a Form PTO/SB/08A, listing the enclosed documents.

This Information Disclosure Statement is being submitted subsequent to a non-final Office Action on the merits in the above-identified application, but prior to a Final Office Action or issuance of a Notice of Allowance, or issuance of any other action closing prosecution on the merits in the above-

identified application. For satisfying requirements of 37 C.F.R. §1.97(c), the following Statement is made under 37 C.F.R. §1.97(e):

Each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

While the enclosed documents are not in English, it is respectfully submitted that requirements of 37 C.F.R. §1.98(a)(3) are satisfied by the respective English abstracts of each of the enclosed documents.

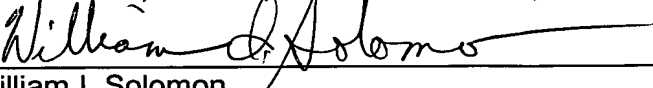
In view of the foregoing, it is respectfully submitted that all applicable requirements of 37 C.F.R. §1.97 and 1.98 have been satisfied, in connection with each of the enclosed documents, listed on the enclosed Form.

Accordingly, consideration of the enclosed documents, upon further examination of the above-identified application, is respectfully requested.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (Case: 500.42846VX1), and please credit any excess fees to such deposit account.

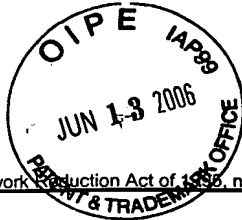
Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP



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Attachments



PTO/SB/08A (08-03)
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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>		Complete if Known	
		Application Number	10/628,275
		Filing Date	July 29, 2003
		First Named Inventor	Mitsuru HASEGAWA
		Art Unit	1763
Examiner Name	Roberts P. CULBERT		
Sheet 1 of 1	Attorney Docket Number	500.42846X00	

U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)				
		US-				
		US-				
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FOREIGN PATENT DOCUMENTS						
Examiner Initials [*]	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ —Number ⁴ —Kind Code ⁵ (if known)				
		JP 3-100942	04/25/91	Hitachi Chemical Co. Ltd.		
		JP 61-3339	01/09/86	Hitachi Ltd.		
		JP 2000-90487	03/31/00	Nippon Telegraph & Telephone		
		JP 2-44539	02/14/90	Sharp KK		

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 1 Applicant's unique citation designation number (optional). 2 See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. 3 Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

If you need assistance in completing the form, call 1-800-PTO-9199 and select option 2.